

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Dureseti CHIDAMBARRAO Group Art Unit: 2813  
Appln. No. : 10/715,400 Examiner: J. M. Mitchell  
Filed : November 19, 2003 Confirmation No.: 5307  
For : SILICON DEVICE ON Si:C-OI AND SGOI AND METHOD OF MANUFACTURE

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

**REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.111**

Sir

In response to the Office Action dated February 7, 2006, Applicants request reconsideration of the rejected claims in view of the following remarks.

Remarks begin on page 2.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.